IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Attn: APPLICATION BRANCH

Akihisa HONGO et al. : Attorney Docket No. 2004 0291

Serial No. NEW

Filed February 26, 2004 :

SUBSTRATE PLATING APPARATUS (Rule 1.53(b) Divisional of Serial No. 09/945,711, Filed September 5, 2001)

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975

CLAIM OF PRIORITY UNDER 35 USC 119

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Applicants in the above-entitled application hereby claim the date of priority under the International Convention of Japanese Patent Application No. 270493, filed September 17, 1997, Japanese Patent Application No. 71370, filed March 5, 1998, Japanese Patent Application No. 96974, filed March 26, 1998 and Japanese Patent Application No. 205138, filed July 21, 1998, as acknowledged in the Declaration of this application.

Certified copies of said Japanese Patent Applications are of record in grand-parent application Serial No. 09/154,895, filed September 17, 1998.

Respectfully submitted,

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